

APPLICATION TRANSFER REQUEST FOR S.N. 10/020081

Section I. TRANSFER REQUEST BY (PRINT NAME) Rhett R. ...

Date 11/10/02

TO: Art Unit 1755

Class/sub 51/298

From: A.U. 3723

Class 451

REASON:

Polishing pad composition and method  
of making polishing pad. See class definition for  
Class 51 - Abrasive Tool Making Processes, materials or Compositions.

Gatekeeper concurrence \_\_\_\_\_

Hand carried: Personally accepted by \_\_\_\_\_

Section II. DISPOSITION BY RECEIVING TC

A.U. 1750

Date 4/1/03

☐ ACCEPTED BY RECEIVING T.C.

NOT ACCEPTED

☐ Forward to Post Classifier

☒ Return to Originating Technology Center /AU 3723

REASON:

~~The abrasive comp. being claimed~~ only a polishing pad & method  
of making, appear to go - 451/526+, 534.

Related to 10/020,082  
DISPOSITION BY RECEIVING TC POST CLASSIFIER

☐ This dispute was resolved. Forward to Class/Sub \_\_\_\_\_ TC/AU \_\_\_\_\_ Post Classifier \_\_\_\_\_ Date \_\_\_\_\_

Concurring \_\_\_\_\_ Date \_\_\_\_\_

☒ This dispute was not resolved, forward to DISPUTE RESOLUTION PANEL

Post Classifier Assessment:

person i.e. Dave Scherbel

Gatekeeper Concurrence \_\_\_\_\_

Section III. DISPOSITION BY DISPUTE RESOLUTION PANEL

Date \_\_\_\_\_

Panel Decision: Forward to Technology Center / Art Unit \_\_\_\_\_

Class/sub \_\_\_\_\_

REASON:

Panel Member \_\_\_\_\_ Concurring Panel Member \_\_\_\_\_

☐ This application MAY be returned to the dispute resolution panel if reconsideration is desired (use form 447R).

☐ This application MAY NOT be returned to the dispute resolution panel. THIS IS A FINAL DISPOSITION.